IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

PATENT

Applicant(s):	Shiu-Ko JANGJIAN, et al.	**Docket No.:**	39524.8100
Serial No.:	10/679,764	**Group Art Unit:**	1762
Filed:	October 6, 2003	**Examiner:**	David Turocy
Title:	**METHOD OF FORMING INTER-METAL DIELECTRIC LAYER STRUCTURE**	**Confirmation No.:**	8562

AMENDMENT AND RESPONSE TO OFFICE ACTION

Mail Stop Amendment
Commissioner for Patents
P.O. Box 1450
Alexandria, Virginia 22313-1450

Dear Sir:

In response to the Office Action mailed on January 3, 2007, please consider the following amendments and remarks. **This Response is being timely filed within the shortened statutory period of 1 month of the mailing date of the Office Action, so that no extension fee applies. If it is determined that there is a further fee associated with this Response, the United States Patent and Trademark Office is requested to consider this Response (with a petition if necessary) and charge the appropriate fee to Deposit Account No. 19-2814.**

Amendments to Claims are reflected in the listing of claims which begin on page 2.

Remarks begin on page 5.